

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named		Conf. No. 7978
Inventor :	Benjamin Y.H. Liu	
Appln. No.:	10/769,011	Group Art Unit: 1792
Filed :	January 30, 2004	
For :	HIGH-PERFORMANCE AND MULTI-LIQUID-PERCURSOR VAPORIZATION IN SEMICONDUCTOR THIN FILM DEPOSITION	Examiner: Bueker, Richard R.
Docket No.:	M419.12-0043	

REQUEST FOR APPROVAL OF FORMAL DRAWINGS

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

VIA ELECTRONIC FILING
DECEMBER 4, 2008

Enclosed are **EIGHT** (8) sheets of formal drawings for filing in the above-identified application.

Respectfully submitted,

WESTMAN, CHAMPLIN & KELLY, P.A.

By: NICKOLAS E. WESTMAN
Nickolas E. Westman, Reg. No. 20,147
900 Second Avenue South, Suite 1400
Minneapolis, Minnesota 55402-3319
Phone: (612) 334-3222 Fax: (612) 334-3312

NEW:rkp